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In re Application of: Shen et al.	Group Art Unit: 1763
Application No: 09/507,629	Examiner: Allan W. Olsen
Confirmation No: 7912	Attorney Docket No: 001945 USA P 03/ETCH/SILICON/JB1
Filed: 2/18/2000	September 4, 2003 San Francisco, California
Title: SELF-CLEANING PROCESS FOR ETCHING SILICON-CONTAINING MATERIAL	

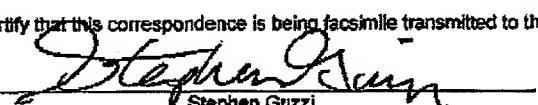
AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents

Via Facsimile Transmission
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Examiner Olsen:

This communication is in response to the Office Action mailed on June 4, 2003, and is being timely filed within three months thereof.

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By:  Stephen Guzzi	Date: September 4, 2003